DSG Ansys R&D Meeting

Date: May 25, 2023

Time: 2:00 PM - 2:30 PM

Attendees: Aaron Brown, Pablo Campero, Brian Eng, and Marc McMullen

1. EIC beampipe test stand thermal analysis

Pablo Campero, Brian Eng, and Marc McMullen

- 1. Completed model modifications to improve simulation
 - Redid the cap that represents the O-ring used in the test stand, using rubber silicon
- 2. Discussed the set boundary and cell conditions in Fluent
 - Fixed temperature for heater pipe at 102°C
 - Inlet air temperature of 23°C
 - Convection for silicon pipe with air temperature at 23°C and 5 W/m²K
- 3. Ran simulations for different flow rates from 0 to 200 l/min
 - Generated velocity and temperature contour plots
 - Generated plot of inlet silicon pipe temperature vs flow rate; compared simulation results to test stand measurements
 - Generated plot of outlet silicon pipe temperature vs flow rate; compared simulation results to test stand measurements

Test Stand EIC-Si Sensor L1 Outlet Temperature Vs Air Flow Air at annulus space & ambient at 23 °C Test Stand Mo

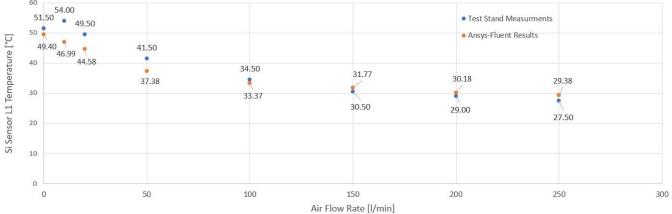


Fig.1. Silicon temperature vs air flow rate

- 4. Discussed modifications to the model to improve simulation
 - Heater pipe in the test stand does not have a fixed temperature
 - Will change the fixed temperature boundary condition to a heat source boundary condition
 - Will monitor maximum temperature at the upper section of the heater pipe and compare with the test stand temperatures